

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/575,187	FUTAGAWA ET AL.	
Examiner		Keath T. Chen	Art Unit	Page 1 of 1

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*	C	US-6,204,174	03-2001	Glew et al.	438/680
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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